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6/6/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Takayuki WATANABE, et al.

Serial No.: 10/024,391

Group Art Unit: 1765

Filed: December 21, 2001

P.T.O. Confirmation No.: 5820

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND  
METHOD OF MANUFACTURING OPTICAL WAVE GUIDE**

PRELIMINARY AMENDMENT

Commissioner for Patents  
Washington, D.C. 20231

April 10, 2002

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

IN THE SPECIFICATION:



Amend the specification as follows:

Please delete the paragraph beginning at page 18, line 33 and ending at page 18, line 35.

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